

INVENTOR INFORMATION

Inventor One Given Name:: Hideto
Family Name:: OHNUMA
Postal Address Line One:: c/o Semiconductor Energy Laboratory Co., Ltd
Postal Address Line Two:: 398, Hase,
City:: Atsugi-shi
State or Province:: Kanagawa-ken
Country:: Japan
Postal or Zip Code:: 243-0036
Citizenship Country:: Japan

CORRESPONDENCE INFORMATION

Correspondence Customer Number:: 22204
Fax One:: (703) 883-0370
Electronic Mail One:: pluther@nixonpeabody.com

APPLICATION INFORMATION

Title Line One:: METHOD OF MANUFACTURING SEMICONDUCTOR DE
Title Line Two:: VICE
Total Drawing Sheets:: 13
Formal Drawings?:: Yes
Application Type:: Utility
Docket Number:: 740756-2422
Secrecy Order in Parent Appl.?:: No

REPRESENTATIVE INFORMATION

Representative Customer Number:: 22204
Registration Number One:: 38285
Registration Number Two:: 35483
Registration Number Three:: 45285
Registration Number Four:: 32815
Registration Number Five:: 26477

PRIOR FOREIGN APPLICATIONS

Foreign Application One:: 2001-019293
Filing Date:: 01-26-2001
Country:: Japan
Priority Claimed:: Yes

Source:: PrintEFS Version 1.0.1